



PATENT APPLICATION
IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re U.S. Patent Application)

Applicant: Hongyong Zhang)

Serial No.: 09/468,489)

Filing Date: December 20, 1999)

For: THIN FILM TRANSISTOR HAVING
LIGHTLY AND HEAVILY DOPED
SOURCE/DRAIN REGIONS AND ITS
MANUFACTURE)

Art Unit: 2814)

Examiner: Quach, T.)

I hereby certify that this paper is being deposited with
the United States Postal Service as FIRST-CLASS mail
in an envelope addressed to: Assistant Commissioner for
Patents, Washington, D.C. 20231, on this date.

January 7, 2002 *Josh Snider*
Date Registration No. 47,954
F-CLASS.WCM

TC 2800 MAIL ROOM

RECEIVED
FEB - 7 2002

Assistant Commissioner for Patents
Washington, D.C. 20231

Dear Sir:

Please direct all future correspondence concerning the above-identified
Application to the following address:

Patrick G. Burns, Esq.
Greer, Burns & Crain, Ltd.
300 S. Wacker Dr., Suite 2500
Chicago, Illinois 60606
(312) 360-0080

Respectfully submitted,
GREER, BURNS & CRAIN, LTD.

By

Josh C. Snider
Josh C. Snider
Registration No. 47,954

Customer Number 24978

January 7, 2002

300 S. Wacker Dr, Suite 2500
Chicago, Illinois 60606
(312) 360-0080

K:\1612\63479\ADDCHG.DOC